

<b>Notice of References Cited</b>		Application/Control No.	Applicant(s)/Patent Under Reexamination CHEN ET AL.	
		10/671,041 <i>EDNA WONG</i>	Examiner Edna Wong	Art Unit 1753

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,831,510	11-1998	Zhang et al.	338/22R
*	B	US-2002/0050914	05-2002	CHIANG et al.	338/22.00R
C	US-				
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F	US-				
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H	US-				
I	US-				
J	US-				
K	US-				
L	US-				
M	US-				

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)			
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